



IFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Fan SHI et al.

Group Art Unit: 2852

Application No.: 10/707,576

Examiner: H. TRAN

Filed: December 22, 2003

Docket No.: 114058

For: SYSTEMS AND METHODS FOR IN SITU SETTING CHARGE VOLTAGES IN A
DUAL RECHARGE SYSTEM

RESPONSE TO QUAYLE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the June 1, 2005 Office Action, please consider the following:

Amendments to the Specification;

Amendments to the Claims as reflected in the listing of claims; and

Remarks.